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Att'y. Docket No.

Mo-6644 LeA-34 975

Serial No.

29 998 560

Applicant

Kristina Vogt et al.

Filing Date

11-29-01

Group

2812

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE F APPRO- PRIATE
<i>L.J.M-E</i>	<i>4915890</i>	04 10 90	Jones	252	313.2	
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FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
						Yes <input type="checkbox"/> No <input type="checkbox"/>
<i>L.J.M-E</i>	EP AL 0 634 465 A1	01/18/95	Europe	—	—	
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OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

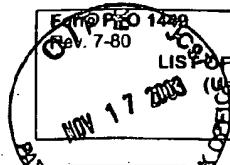
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Atty. Docket No.
Mo-6644/LeA-34,976

Serial No.
09/998,560

Applicant
Kristina Vogt et al

Filing Date
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U.S. PATENT DOCUMENTS

EXAMINER INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AA	5,614,449	03/25/97	Jensen	501	38	
AB	5,755,946	05/26/98	Feronato	205	110	
AC						
AD						
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AF						
AG						
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FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							Yes	No*
Lynette, AL		164439	10/31/75	Hungary	—	—		x
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AN								
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Atty. Docket No.
Mo6644-LeA 34.976
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U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
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US PTO
JC973 09/98560
11/25/01

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION Yes No*
LJME	AL	WO 00/00567	01/06/2000	World Patent	—	—	
LJME	AM	WO 00/24842	05/04/2000	World Patent	—	—	
LJME	AN	WO 99/64527	12/16/99	World Patent	—	—	
LJME	AO	WO 99/47618	09/23/99	World Patent	—	—	
LJME	AP	WO 99/67056	12/29/99	World Patent	—	—	

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

LJME	AR	Microchip Fabrication: A Practical Guide to Semiconductor Processing, Peter Van Zant ed., McGraw-Hill (month unavailable) 2000, pages 302-309 & 401-403
LJME	AS	Copper CMP: A Quistion of Tradeoffs, Peter Singer, Semiconductor International, Verlag Cahner, May 2000, pages 73-84
LJME	AT	Chemical Mechanical Planarization of Microelectronic Material, J.M. Steigerwald, S.P. Murarka & R.J. Gutmann, John Wiley & Sons, Inc. (month unavailable) 1997, CMP Variable and Manipulations, pages 42-43
EXAMINER	Lynette T. Alme-Ermini	DATE CONSIDERED 4/22/2004
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